

Notice of References Cited		Application/Control No. 10/707,979	Applicant(s)/Patent Under Reexamination DENTON ET AL.	
		Examiner MARK A. FLEISCHER	Art Unit 3624	Page 1 of 2

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-7,197,469 B2	03-2007	Hegde et al.	705/8
*	B US-7,464,147 B1	12-2008	Fakhouri et al.	709/223
*	C US-6,701,201 B2	03-2004	Hegde et al.	700/107
*	D US-6,151,582 A	11-2000	Huang et al.	705/8
*	E US-5,093,794 A	03-1992	Howie et al.	700/100
*	F US-6,498,786 B1	12-2002	Kirkby et al.	370/322
*	G US-2003/0208392	11-2003	Shekar et al.	705/8
*	H US-2004/0030428 A1	02-2004	Crampton et al.	700/101
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	de Farias, D. "THE LINEAR PROGRAMMING APPROACH TO APPROXIMATE DYNAMIC PROGRAMMING: THEORY AND APPLICATION", dissertation, Stanford University, June 2002.
*	V	Leachman, R. et al. "IMPRess: An Automated Production-Planning and Delivery-Quotation System at Harris Corporation-Semiconductor Sector", Interfaces Vol. 26, No. 1, 1996
*	W	de Farias, D., Van Roy, B. "THE LINEAR PROGRAMMING APPROACH TO APPROXIMATE DYNAMIC PROGRAMMING". Operations Research, Vol. 51, No. 6, November-December 2003, pp. 850-865
*	X	Yi-Feng Hung and Robert C. Leachman, "A Production Planning Methodology for Semiconductor Manufacturing Based on Iterative Simulation and Linear Programming Calculations", IEEE TRANSACTIONS ON SEMICONDUCTOR MANUFACTURING, VOL. 9, NO. 2, MAY 1996

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

Notice of References Cited

Application/Control No.

10/707,979

Applicant(s)/Patent Under

Reexamination

DENTON ET AL.

Examiner

MARK A. FLEISCHER

Art Unit

3624

Page 2 of 2

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-			
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U Nagen Nagarur, Prem Vratb, Wanchai Duongsuwarf "Production planning and scheduling for injection moulding of pipe fittings A case study", Int. J. Production Economics 53 (1997) 157-170
*	V Peter Lyon, et al. "Matching Assets with Demand in Supply-Chain Management at IBM Microelectronics", INTERFACES 31: 1 January–February 2001 (pp. 108–124).
	W
	X

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.